

INFORMATION DISCLOSURE CITATION

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Docket Number (Optional)
100-23800 (P05751)

Application Number
10/728,319

Applicant(s)
Peter J. Hopper et al.

Filing Date
December 4, 2003

Group Art Unit
Unknown

U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
<i>PH</i>		10/728,132		Peter J. Hopper et al.			12/04/03
<i>PH</i>		10/727,838		Peter J. Hopper et al.			12/04/03

FOREIGN PATENT DOCUMENTS

	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

EXAMINER *Sam* DATE CONSIDERED *2/17/05*

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New 10/728, 39

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Filing Date
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Group Art Unit
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U.S. PATENT DOCUMENTS

EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
<i>Dr</i>		U.S. Appln. 10/004,977		Yegnashankaran et al.			12/03/01
		5,530,552	06/25/96	Mermagen et al.	356	401	12/28/94
		4,782,028	11/01/88	Farrier et al.	437	3	08/27/87
		3,937,579	02/10/76	Schmidt	356	144	11/15/73
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		5,142,756	09/01/92	Ibaraki et al.	29	25.01	10/19/90
<i>Dr</i>		5,240,882	08/31/93	Satoh et al.	437	226	07/28/92

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	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO
<i>Dr</i>		64-19729	01-23-89	Japan	H01L	21/304		✓

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

<i>Dr</i>	U. Simu et al., "Limits in Micro Replication of CVD Diamond By Moulding Technique", 1997, [online], [retrieved on 2003-11-16]. Retrieved from the Internet: <URL:http://www.angstrom.uu.se/solidstatephysics/joakim/limits.pdf>. pp. 1-11, (note page 5, column 2, lines 15-23).
<i>Dr</i>	E. Hui et al., "Carbonized Parylene as a Conformal Sacrificial Layer", [online], [retrieved on 2003-11-16]. Retrieved from the Internet: <URL:http://www.bsac.eecs.berkeley.edu/archive/users/hvi-elliott/pdf/sacpaper.pdf>. pp 1-5 (unnumbered), (note page 2, Process Characterization, first paragraph).

EXAMINER *Dr*

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ATTY DOCKET NO.
100-23800 (P05751)

SERIAL NO. 10728319
New

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Unknown

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<u>Dr</u>	5,362,683	11/08/94	Takenaka et al.	437	226	03/04/94
	5,739,067	04/14/98	DeBusk et al.	438	618	12/07/95
	5,250,460	10/05/93	Yamagata et al.	437	62	10/09/92
	6,110,825	08/29/00	Mastromatteo et al.	438	667	11/25/98
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	5,627,106	05/06/97	Hsu	438	459	05/06/94
	5,426,072	06/20/95	Finnila	437	208	01/21/93
<u>Dr</u>	6,252,300 B1	06/26/01	Hsuan et al.	257	686	03/01/99

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<u>Dr</u>	G. Stemme, "Fabrication of MEMS", [online], [retrieved on 2003-11-16], Retrieved from the Internet: <URL: http://mmadoug.eng.vci.edu/PDF%20Files/Stemme%20Fabrication.pdf >, pp. 1-9 (unnumbered), (note page 3.)

EXAMINER

Dr

DATE CONSIDERED

2/17/05

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ATTY DOCKET NO.
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SERIAL NO. New 10/728,219

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*EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
<u>JS</u>	6,015,726	01/18/00	Yoshida	438	202	03/24/98
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						YES	NO

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